First Named Inventor	Naoto Kawamura et al.			
Serial No.	Filed Herewith	INFORMATION		
Filing Date	Filed Herewith	DISCLOSURE STATEMENT		
Group Art Unit	Unknown			
Examiner Name	Unknown			
Confirmation No.	Unknown			
Attorney Docket No.	10991153-11			

Title: FLUID EJECTION DEVICE AND METHOD OF MANUFACTURE

Commissioner for Patents MS Patent Application P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

In compliance with 37 C.F.R. §§ 1.56 and 1.97, et seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

Further pursuant to 37 C.F.R. 1.98(d), because all of the references listed on the attached Form 1449 have been previously submitted and made of record in the grand-parent application, U.S. Patent Application 09/556,026, filed April 20, 2000, copies of the references previously made of record in the parent application are not submitted herewith.

Serial No. Filed Herewith

Title: FLUID EJECTION DEVICE AND METHOD OF MANUFACTURE

If the Examiner has any questions or concerns regarding this application, please contact the undersigned at the number listed below.

Respectfully submitted,

Date: 09-09-2003

Tod A. Myrum Reg. No. 42,922

Attorneys for Applicant HEWLETT-PACKARD COMPANY Intellectual Property Administration 16399 W. Bernardo Drive P.O. Box 272400 Fort Collins, CO 80527-2400

PATENT APPLICATION

Sheet 1 of 1

	<u> </u>				LATTY DOCKET NO	APPLICATION NO. CONFIRMA	TION NO
FORM PTO-1449					ATTY. DOCKET NO. 10991153-11	APPLICATION NO. CONFIRMA	HON NO
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			APPLICANT Naoto Kawamura et al.				
						FILING DATE	GROUP
			Herewith				
			REFERE	NCE	DESIGNATION	U.S. PA	ATEN
XAMINER INITIAL		DOCUMENT NUMBER	PUBLICATION DATE		Pages, Columns, Lines Whe NAME Relevant Passages or Figures A		e pear
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	1L	EP 0593175A2	April 1994	Hewlett-Packard Co.			
	1M	EP 0646466A2	April 1995	Hewlett-Packard Co.			
	1N	WO 99/65690	Dec. 1999	Lexm	ark Int'l Inc.		
	10	WO 99/65691	Dec. 1999	Lexmark Int'l Inc.			
	1P						<u> </u>
	1	OTHER REF	ERENCES (includ	ing A	uthor, Title, Date, P	Pertinent Pages, etc.)	
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